

Course Schedule, group M16-303**MONDAY**

08:30 — 10:05	■	LEC	Opt	Military Training (2017-02-06 — 2017-05-15) ♣ dep.20
10:15 — 16:05	■	SEM	Opt	Military Training (2017-02-06 — 2017-05-15) ♣ dep.20

WEDNESDAY

10:15 — 11:50	■	LEC		Principles of Nanobiology (2017-02-08 — 2017-03-01) ♣ Chudinova G.K. ♣ 98-8
	■	SEM		Principles of Nanobiology (2017-03-08 — 2017-05-17) ♣ Chudinova G.K. ♣ 98-8
11:55 — 13:30	■	LAB		Principles of Nanobiology (2017-02-08 — 2017-04-26) ♣ Chudinova G.K. ♣ K-417
13:35 — 15:15	☑	SEM		Principles of Nanobiology ♣ Chudinova G.K. ♣ K-417

THURSDAY

08:30 — 10:05	☑	LEC	Elect	Optical Methods in Information Processing ♣ Cheryomhin P.A., Krasnov V.V. ♣ dep.37
	☑	LEC	Elect	Physical Optics ♣ Kanavin A.P. ♣ K-205
	☑	SEM	Elect	Optical Methods in Information Processing ♣ Krasnov V.V., Cheryomhin P.A. ♣ dep.37
	☑	SEM	Elect	Physical Optics ♣ Kanavin A.P. ♣ K-205
10:15 — 11:50	■	LEC		Principles of Information Security (2017-02-09 — 2017-04-27) ♣ Malyuk A.A. ♣ 403
11:55 — 13:30	■	LEC		Selected Chapters of Higher Mathematics (2017-02-09 — 2017-05-18) ♣ Ryabov P.N. ♣ 404
13:35 — 15:15	☑	SEM		Academic Research Practice (2017-02-16 — 2017-06-08) ♣ Pereverzev V.G. ♣ dep.87
16:15 — 17:50	☑	SEM	Elect	Physical Principles of Surface Processing Technology ♣ Menushenkov A.P. ♣ 7a-4
	☑	LEC	Elect	Physical Principles of Surface Processing Technology (2017-02-16 — 2017-03-30) ♣ Menushenkov A.P. ♣ E-204
	☑	SEM	Elect	Physical Principles of Surface Processing Technology (2017-04-13 — 2017-05-25) ♣ Menushenkov A.P. ♣ E-204
	☑	SEM	Elect	Physical Principles of Surface Processing Technology (2017-04-13 — 2017-05-25) ♣ Menushenkov A.P. ♣ E-204

FRIDAY

10:15 — 11:50	■	LEC	Elect	Introduction to Problems of Synchrotron Radiation (2017-02-10 — 2017-03-03) ♣ Zavestovskaya I.N. ♣ B-215
	■	SEM	Elect	Introduction to Problems of Synchrotron Radiation (2017-03-10 — 2017-05-19) ♣ Zavestovskaya I.N. ♣ B-215
12:45 — 14:20	■	SEM		English Language ♣ Komochkina E.A. ♣ B-401
14:30 — 16:05	■	SEM		Selected Chapters of Higher Mathematics ♣ Ivanova Y.S., Sinelschikov D.I. ♣ K-210